Electronic Acknowledgement Receipt		
EFS ID:	4747400	
Application Number:	10801208	
International Application Number:		
Confirmation Number:	2034	
Title of Invention:	Methods of manufacturing semiconductor devices having a ruthenium layer via automatic layer deposition	
First Named Inventor/Applicant Name:	Kwang-hee Lee	
Customer Number:	20792	
Filer:	D. Randal Ayers/Paula Fisher	
Filer Authorized By:	D. Randal Ayers	
Attorney Docket Number:	5649-1277	
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Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$180
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Deposit Account	500220
Authorized User	

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Document Description	83be14dce20459fe50de638751926389eb2	
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Information Disclosure Statement (IDS) Filed (SB/08)	Description Start End	
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2 Foreign Reference	·	
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Warnings:	5649-1277_For_Ref_KR_2002_	14
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NPL Documents	02_0094175A.pdf a33a5eae356bb159278c986ee6e1b703523	10
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.